

Application No. 10/576,486
Paper Dated: January 8, 2009
In Reply to USPTO Correspondence of October 8, 2008
Attorney Docket No. 0388-061179

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/576,486 Confirmation No. : 6114
Applicant : Chie Ishikawa et al.
Filed : December 21, 2006
Title : SURFACE DEFECT INSPECTING METHOD AND
DEVICE
Group Art Unit : 2877
Examiner : Iyabo S. Alli
Customer No. : 28289

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated October 8, 2008, Applicants submit the following amendments and remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.

I hereby certify that this correspondence is being electronically submitted to the United States Patent and Trademark Office on January 8, 2009.

01/08/2009

Date

Signature

Mary Ann Mulvihill

Typed Name of Person Signing Certificate